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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/734,583  
Applicant : Hidetoshi ANDOU  
Filed : December 15, 2003  
TC/A.U. : 3738  
Examiner :  
Docket No. : 2923-595  
Customer No. : 06449  
Confirmation No. : 2600

INFORMATION DISCLOSURE STATEMENT

Director of the United States Patent  
and Trademark Office  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

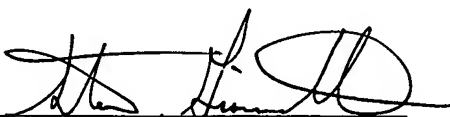
Under the provisions of 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant submits herewith information that the Office may wish to consider in examination of the subject application.

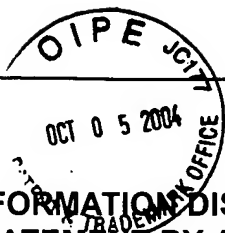
Materials submitted for consideration are listed on the attached form PTO-1449.

This statement is being provided prior to the receipt of the first Office Action on the merits.

U.S. Patents 6,551,801 B1, 5,399,677 as well as EP 0433225 were cited by the U.S. Patent and Trademark Office in Application Serial No. 10/414,954, filed April 16, 2003. Application No. 10/734,583 claims priority to Application No. 10/414,954 under 35 U.S.C. § 120.

Respectfully submitted,

By   
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# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

*Complete if Known*

Application Number	10/734,583
Filing Date	December 15, 2003
First Named Inventor	Hidetoshi ANDOU
Group Art Unit	3738
Examiner Name	

Sheet	1	of	1	Attorney Docket Number	2923-595
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## **U.S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code <sup>2</sup> (if known)		
		5,399,677		Wolfman et al.	03-21-1995
		5,807,713		Hötten et al.	09-15-1998
		6,120,760		Hötten et al.	09-19-2000
		6,162,257		Gustilo et al.	12-19-2000
		6,171,584		Hötten et al.	01-09-2001
		6,197,550		Hötten et al.	03-06-2001
		6,531,450		Hötten et al.	03-11-2003
		6,551,801		Andou et al.	04-22-2003

## **FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T <sup>6</sup>
		Office <sup>3</sup> Code	Number <sup>4</sup>	Kind <sup>5</sup> (if known)			
		WO	00/21998		Hoechst Marion Roussel Ltd.	04-20-2000	
		WO	99/66060		Hoechst Marion Roussel Ltd.	12-23-1999	
		WO	97/04095		Hoechst Marion Roussel Ltd.	02-06-1997	AB
		EP	0433225		Ciba-Geigy AG	06-19-1991	

Examiner  
Signature

Date  
Considered

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two-letter code.

<sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.